



# ***Excellent Presentation Award***

**in International Symposium on Creation of Life  
Innovation Materials for Interdisciplinary and  
International Researcher Development Satellite  
(iLIM-s)**

**S2-P-41**

**“High performance oxide thin-film transistors  
fabricated by a total nano-rheology printing  
(nRP) method”**

**by**

**Phan Trong Tue, Kazuhiro Fukuda,  
Jinwang Li, and Tatsuya Shimoda**

**Laboratory for Materials and Structures, Tokyo Institute of  
Technology School of Materials Science, Japan Advanced  
Institute of Science and Technology**

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**Symposium Chair, Masakuni Ozawa**

